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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

: **Confirmation No. 8539**

Yoichiro NUMASAWA et al.

: Attorney Docket No. 2003\_1164A

Serial No. 10/645,908

: Group Art Unit 2891

Filed August 22, 2003

: Examiner Asok K. Sarkar

METHOD FOR FORMING AN OXYGEN- OR  
NITROGEN-TERMINATED SILICON  
NANOCRYSTALLINE STRUCTURE AND AN  
OXYGEN- OR NITROGEN-TERMINATED  
SILICON NANOCRYSTALLINE  
STRUCTURE FORMED BY THE METHOD

: **Mail Stop Amendment**

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEE FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975.

**PATENT OFFICE FEE TRANSMITTAL FORM**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
Sir:

Attached hereto is a check in the amount of \$1,020.00 to cover Patent Office fees relating to filing the following attached papers:

Petition for Extension of Time ..... \$1,020.00

A duplicate copy of this paper is being submitted for use in the Accounting Division, Office of Finance.

*The Commissioner is authorized to charge any deficiency or to credit any overpayment associated with this communication to Deposit Account No. 23-0975, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.*

Respectfully submitted,

Yoichiro NUMASAWA et al.

For: Michael R. Davis  
Michael R. Davis  
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By: Amy E. Schmid  
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July 16, 2007

[Check No. 81292]  
2003\_1164A



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 8539**  
Yoichiro NUMASAWA et al. : Attorney Docket No. 2003\_1164A  
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METHOD FOR FORMING AN OXYGEN- OR : **Mail Stop Amendment**  
NITROGEN-TERMINATED SILICON  
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**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEE FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975.

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of January 16, 2007.

The fee of \$1,020.00 is

- ☒ submitted herewith.  
☐ to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.  
  
☐ Small entity status of this application is established by a Small Entity Status Assertion which  
☐ is enclosed.  
☐ has been previously submitted.

Respectfully submitted,

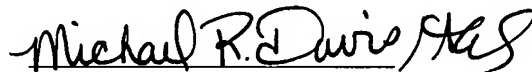
Yoichiro NUMASAWA et al.

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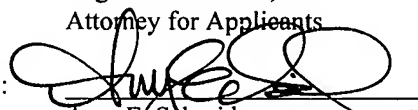
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For:



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July 16, 2007